



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.	10/722,984	Confirmation No.	9025
First Inventor	Mohamed N. Darwish	Filing Date	11/25/2003
Tech. Center/ Art Unit	2814	Examiner	Hoai V. Pham
Title:	Trench MIS Device With Thick Oxide Layer In Bottom Of Gate Contact Trench		
Docket No.:	SCX005-3P US	Customer No.:	34036

Santa Clara, California
June 25, 2005

Mail Stop Amendment
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office Action dated March 22, 2005, please amend the above-identified application as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Drawings begin on page 4 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

Remarks/Arguments begin on page 5 of this paper.

An **Appendix** including amended drawing figures is attached following page 6 of this paper.